

P-602 PiezoMove Flexure Actuator with High Stiffness

Integrated Guiding System, High Force and Large Travel Ranges



P-602 linear actuator family featuring travel ranges of 100, 500, and 1000 µm (from left to right)

- Frictionless Flexure Guiding System for Straight Motion
- Integrated Motion Amplifier for Travel Ranges to 1 mm
- High Dynamics and Stiffness, Forces to 400 N, Backlash-Free Construction
- Outstanding Lifetime Due to PICMA® Piezo Actuators
- Available with Integrated Position Sensor
- Custom Designs with Larger Travel or Faster Response and Non-Magnetic Versions Feasible
- Ideal for OEM-Applications in Adaptronics, Biotechnology or Microfluidics

P-602 PiezoMove flexure-guided piezo actuators integrate a frictionless high-efficiency motion amplifier to combine large travel ranges up to 1 millimeter

Application Examples

- Nanopositioning
- Adaptronics
- Active vibration control
- Nano-imprinting
- Active Tool control
- Laser technology
- Semiconductor technology
- Active and adaptive optics

with high stiffness and very fast response. They do not contain any components that require maintenance or are subject to wear or tear. The flexure guides eliminate tip motion permitting only for a very slight tilt at the drive head. This design feature saves the cost for additional guiding systems when integrating these actuators in applications for the active control of tools, vibrations or deformations for accuracies down to a few 10s of nanometers.

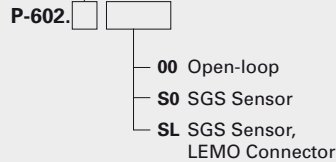
Options and Custom Versions

For OEM applications, PiezoMove actuators can be modified in various ways to suit the customer's requirements. The

Ordering Information

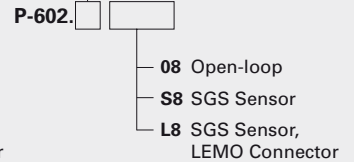
PiezoMove® OEM Linear Actuator with High Stiffness

- 1 Travel Range 100 µm
- 3 Travel Range 300 µm
- 5 Travel Range 500 µm
- 8 Travel Range 1000 µm



PiezoMove® OEM Linear Actuators with High Force

- 1 Travel Range 100 µm
- 3 Travel Range 300 µm
- 5 Travel Range 500 µm



Ask about custom designs!

stiffness and force generation can be influenced via the lever design and the dimensions of the piezo ceramics used in the actuator. If only a small force and low guiding accuracy are required, large strokes of several 100 µm and high frequencies can be achieved with small actuators, e.g. for micropump drives. For high-accuracy applications, an integrated position feedback sensor is available. The actuators were designed to allow for considerable cost savings in large production runs.

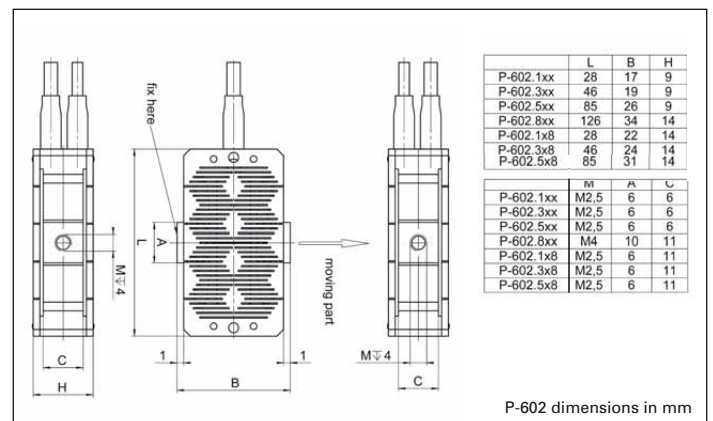
OEM Control Electronics

PI also supplies a variety of controllers to match the actuators. These range from simple amplifier modules (see p. 2-164) and analog closed-loop OEM controllers (see p. 2-110)

to high-performance digital controllers (see p. 2-100ff). The great choice of actuators and controllers allows customers to select the optimum combination of performance and cost for their application.

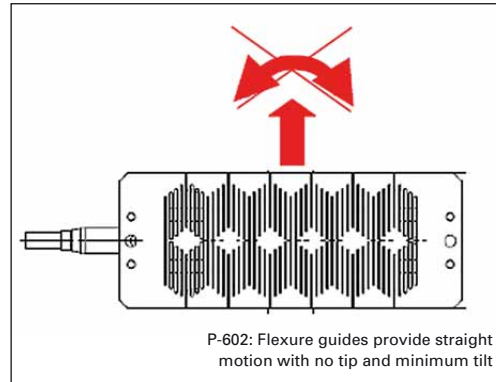
Ceramic-Insulated Piezo Actuators Provide Superior Lifetime

The highest possible reliability is assured by employing the award-winning PICMA® multi-layer piezo actuators. PICMA® actuators are the only actuators on the market with a ceramic-only insulation which makes them resistant to ambient humidity and leakage-current failures. They are thus far superior to conventional actuators in reliability and lifetime.





PI offers a large variety of standard and custom lever-amplified piezo actuators for almost any application



Technical Data (preliminary)

Model	P-602.100 P-602.1S0 P-602.1SL	P-602.300 P-602.3S0 P-602.3SL	P-602.500 P-602.5S0 P-602.5SL	P-602.108 P-602.1S8 P-602.1L8	P-602.308 P-602.3S8 P-602.3L8	P-602.508 P-602.5S8 P-602.5L8	P-602.800 P-602.8S0 P-602.8SL	Units	Tolerance
Active axes	X	X	X	X	X	X	X		
Motion and positioning									
Integrated sensor	- / SGS / SGS	- / SGS / SGS	- / SGS / SGS	- / SGS / SGS	- / SGS / SGS	- / SGS / SGS	- / SGS / SGS		
Open-loop travel, -20 to +120 V	120	300	600	100	300	500	1000	µm	min. (+20%/-0)
Closed-loop travel	- / 100 / 100	- / 300 / 300	- / 500 / 500	- / 100 / 100	- / 300 / 300	- / 500 / 500	- / 1000 / 1000	µm	
Open-loop resolution	0.2	0.3	0.4	0.2	0.3	0.4	0.5	nm	typ.
Closed-loop resolution	- / 2 / 2	- / 3 / 3	- / 3 / 3	- / 2 / 2	- / 3 / 3	- / 3 / 3	- / 7 / 7	nm	typ.
Linearity, closed-loop	- / 0.5 / 0.5	- / 0.5 / 0.5	- / 0.5 / 0.5	- / 0.5 / 0.5	- / 0.5 / 0.5	- / 0.5 / 0.5	- / 1.5 / 1.5	%	typ.
Repeatability	- / 10 / 10	- / 20 / 20	- / 35 / 35	- / 10 / 10	- / 20 / 20	- / 35 / 35	- / 60 / 60	nm	typ.
Mechanical properties									
Stiffness in motion direction	0.8	0.35	0.3	2.3	0.75	0.65	0.4	N/µm	± 20%
Unloaded resonant frequency	1000	450	230	1000	450	230	150	Hz	± 20%
Blocking force	80	105	150	230	225	325	400	N	max.
Drive properties									
Ceramic type	PICMA® P-885	PICMA® P-885	PICMA® P-885	PICMA® P-888	PICMA® P-888	PICMA® P-888	PICMA® P-888		
Electrical Capacitance	1.5	3.1	6.2	6	13	26	39	µF	± 20%
Dynamic operating current coefficient	1.9	1.3	1.6	7.5	5	6	4	µA/(Hz·µm)	± 20%
Miscellaneous									
Operating temperature range	-20 to 80	-20 to 80	-20 to 80	-20 to 80	-20 to 80	-20 to 80	-20 to 80	°C	
Material	Stainless steel	Stainless steel	Stainless steel	Stainless steel	Stainless steel	Stainless steel	Stainless steel		
kg	28 x 17 x 9	46 x 19 x 9	85 x 26 x 9	28 x 22 x 14	46 x 24 x 14	85 x 31 x 14	126 x 34 x 14	mm	
Mass	0.022	0.04	0.105	0.05	0.088	0.215	0.355	kg	± 5%
Cable length	0.5 / 0.5 / 2	0.5 / 0.5 / 2	0.5 / 0.5 / 2	0.5 / 0.5 / 2	0.5 / 0.5 / 2	0.5 / 0.5 / 2	0.5 / 0.5 / 2	m	± 10 mm
Sensor / voltage connection	0- and S-version: open leads SL-version: LEMO connector	0- and S-version: open leads SL-version: LEMO connector	0- and S-version: open leads SL-version: LEMO connector	0- and S-version: open leads L-version: LEMO connector	0- and S-version: open leads L-version: LEMO connector	0- and S-version: open leads L-version: LEMO connector	0- and S-version: open leads SL-version: LEMO connector		

Recommended controller / amplifier
E-610 controller / amplifier see p. 2-110, E-625 bench-top controller see p. 2-114

Linear Actuators & Motors

PiezoWalk® Motors / Actuators

PILine® Ultrasonic Motors

DC-Servo & Stepper Actuators

Piezo Actuators & Components

Guided / Preloaded Actuators

Unpackaged Stack Actuators

Patches/Benders/Tubes/Shear..

Nanopositioning / Piezoelectrics

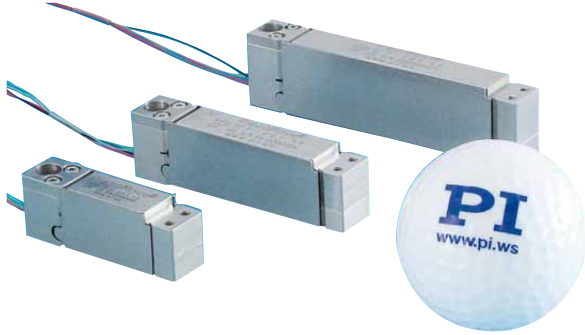
Nanometrology

Micropositioning

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P-601 PiezoMove™ Z-Actuator

Flexure-Guided OEM Piezo Actuator with Long Stroke to 400 µm



PiezoMove™ Lever-amplified piezo actuators of the P-601 series

- Flexure Guidance for Frictionless, Ultra-Straight Motion
- Travel Ranges to 400 µm
- Resolution to 0.2 nm
- High Dynamics and Stiffness
- Custom Designs with Longer Travel or Faster Response and Non-Magnetic Versions Feasible
- Outstanding Lifetime Due to PICMA® Piezo Actuators
- Choice of Closed-Loop and Open-Loop Models
- Ideal OEM Actuator for Precision Motion Control in Optics, Medical, Biotech and Microfluidics Applications

The flexure-guided, lever-amplified PiezoMove™ P-601 actuators provide large vertical travel ranges up to 400 µm, fast response and high positioning accuracy in a very small package. With settling times of only

a few milliseconds and a resolution in the sub-nanometer range they are well suited for both static and dynamic applications.

P-601 PiezoMove™ lever-amplified actuators cover the range between direct-driven pre-loaded piezo translators, such as the P-840 series (see p. 1-74) and single-axis nanopositioning stages, like the P-611 series (see p. 2-20). Compared to direct-driven piezo translators, lever-amplified actuators offer larger travel ranges and much higher lateral stiffness and guiding precision. Compared to single-axis nanopositioning stages, they offer significantly smaller sizes. PiezoMove™ lever-amplified actuators feature a resolution to 0.2 nm and a repeatability to 8 nm.

Application Example

- Nanopositioning
- Imaging
- High-speed switching
- Patch clamp
- Micro-dispensing
- Semiconductor testing
- Adaptronics / Automation
- Photonics / integrated optics
- Biotechnology

OEM Actuator with Integrated Guidance

With their highly precise, frictionless flexure guidance, a very high stiffness and excellent straightness of motion are achieved. Together with their small dimensions and the cost-effective design, the P-601 lever amplified actuators are especially suited for OEM applications. Versions with strain-gauge sensors (SGS) are equipped with a full bridge circuit that is insensitive to thermal drift. Versions without sensors are also available for open-loop applications such as in high-speed switches and pumps. In addition to the standard steel models, special invar and non-magnetic versions are available on request.

Ceramic Insulated Piezo Actuators Provide Long Lifetime

Highest possible reliability is assured by the use of award-winning PICMA® multilayer piezo actuators. PICMA® actuators are the only actuators on the market with ceramic-only insulation, which makes them resistant to ambient humidity and leakage-current failures. They are thus far superior to conventional actuators in reliability and lifetime.

Ordering Information

P-601.1S
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 100 µm, SGS-Sensor

P-601.3S
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 250 µm, SGS-Sensor

P-601.4S
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 400 µm, SGS-Sensor

P-601.1SL
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 100 µm, SGS-Sensor, LEMO Connector

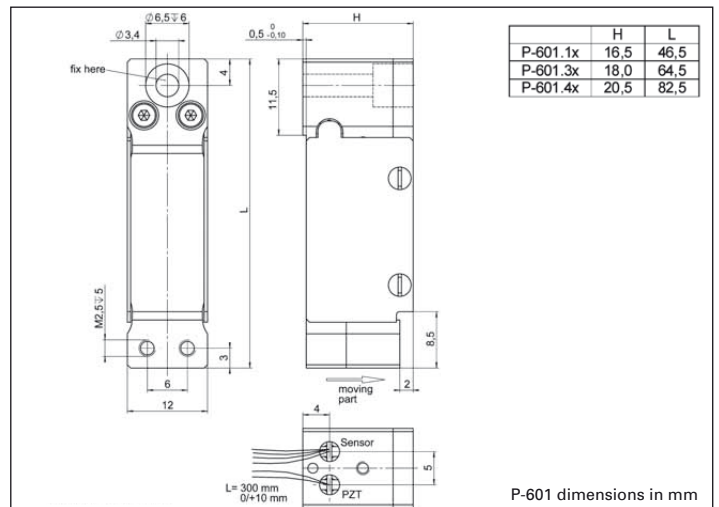
P-601.3SL
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 250 µm, SGS-Sensor, LEMO Connector

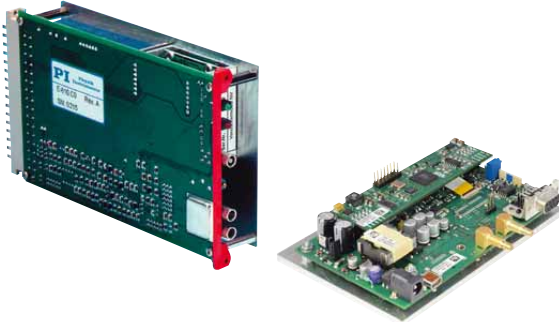
P-601.4SL
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 400 µm, SGS-Sensor, LEMO Connector

P-601.10
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 100 µm, Open-Loop

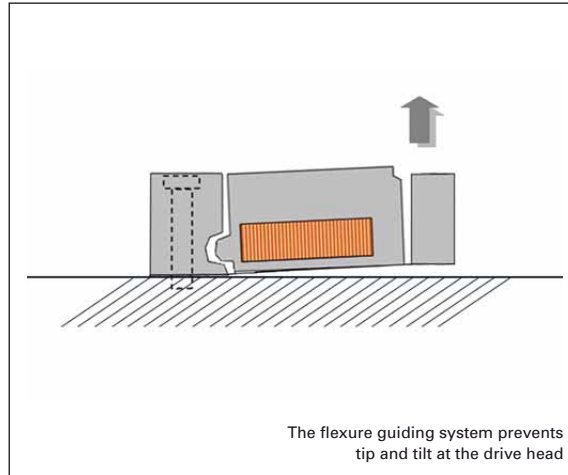
P-601.30
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 250 µm, Open-Loop

P-601.40
PiezoMove™ OEM Flexure-Guided, Lever-Amplified Actuator, 400 µm, Open-Loop





The E-610 analog controller OEM module left or the E-609 digital OEM controller are available for closed-loop versions with position sensor



Linear Actuators & Motors

PiezoWalk® Motors / Actuators

PLine® Ultrasonic Motors

DC-Servo & Stepper Actuators

Piezo Actuators & Components

Guided / Preloaded Actuators

Unpackaged Stack Actuators

Patches/Benders/Tubes/Shear..

Nanopositioning/Piezoelectrics

Nanometrology

Micropositioning

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Technical Data

Model	P-601.1S P-601.1SL	P-601.3S P-601.3SL	P-601.4S P-601.4SL	P-601.x0 Open-loop versions	Units	Tolerance
Active axes	Z	Z	Z	Z		
Motion and positioning						
Integrated sensor	SGS	SGS	SGS	–		
Open-loop travel, -20 to +120 V	100	250	400	as P-601.xS	µm	min. (+20%/0%)
Closed-loop travel	100	250	400	–	µm	calibrated
Open-loop resolution	0.2	0.3	0.4	as P-601.xS	nm	typ.
Closed-loop resolution	2	6	12	–	nm	typ.
Linearity, closed-loop	0.1	0.3	0.3	–	%	typ.
Repeatability	8	10	30	–	nm	typ.
Runout θ_x, θ_y	20 / 10	20 / 10	20 / 10	as P-601.xS	µrad	typ.
Mechanical properties						
Stiffness in motion direction	0.8	0.38	0.28	as P-601.xS	N/µm	±20 %
Unloaded resonant frequency	750	440	350	as P-601.xS	Hz	±20 %
Resonant frequency @ 30 g	620	350	290	as P-601.xS	Hz	±20 %
Push/pull force capacity in motion direction	30/10	20/10	15/10	as P-601.xS	N	Max.
Lateral force	30	30	30	as P-601.xS	N	Max.
Drive properties						
Ceramic type	PICMA® P-885	PICMA® P-885	PICMA® P-885	as P-601.xS		
Electrical capacitance	1.5	3.1	4.6	as P-601.xS	µF	±20 %
Dynamic operating current coefficient	1.9	1.6	1.4	as P-601.xS	µA/(Hz•µm)	±20 %
Miscellaneous						
Operating temperature range	-20 to 80	-20 to 80	-20 to 80	-20 to 80	°C	
Material	Stainless steel	Stainless steel	Stainless steel	Stainless steel		
Mass without cables	0.05	0.08	0.11	as P-601.xS	kg	±5 %
Cable length	S-version: 0.3 SL-version: 1.5	S-version: 0.3 SL-version: 1.5	S-version: 0.3 SL-version: 1.5	0.3	m	±10 mm
Sensor / voltage connection	S-version: open leads SL-version: LEMO	S-version: open leads SL-version: LEMO	S-version: open leads SL-version: LEMO	Open leads (no sensor)		

Recommended controller / amplifier

E-610 controller / amplifier (p. 2-110), E-625 bench-top controller (p. 2-114)